



Attorney's Docket No. 5649-1263

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Jung-Hun Seo et al.

Serial No.: 10/812,768

Filed: March 23, 2006

For: *Metal Deposition Apparatus Used in Fabrication of Semiconductor Devices and Methods of Forming Metal Layers Using the Same*

Confirmation No.: 4965

Group Art Unit: 1763

Examiner: Karla A. Moore

August 21, 2006

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Applicant provides the present Amendment to address the issues raised in the Office Action mailed March 23, 2006 (the "Action").

If any extension of time for the accompanying response or submission is required, Applicant requests that this be considered a petition therefor. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to Deposit Account No. 50-0220.

**Amendments to the Claims** are reflected in the Listing of Claims, which begins on page 2 below.

**Remarks** begin on page 8 below.

08/23/2006 RFEKADU1 00000052 10812768

01 FC:1201 200.00 OP  
02 FC:1202 50.00 OP